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Docket No. YOR920030175US1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Patent Application**

Applicant(s): Allen et al.  
Case: YOR920030175US1  
Serial No.: 10/661,041  
Filing Date: September 12, 2003  
Group: 2811  
Examiner: Cuong Q. Nguyen

I hereby certify that this paper is being deposited on this date with the  
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Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature: Susan Futura Date: November 1, 2005

Title: Techniques for Patterning Features in Semiconductor Devices

**RESPONSE AFTER FINAL REJECTION**

Mail Stop AF  
Commissioner for Patents  
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Sir:

In response to the outstanding final Office Action dated July 1, 2005, Applicants submit the following remarks.